

Appl. No. 09/802,693

PATENT

Amdt. dated January 6, 2004

Reply to Office Action of June 25, 2003 and the Notice of  
Non-Compliant Amendment mailed December 11, 2003 and  
December 11, 2003

**Amendments to the Specification:**

Please replace the paragraph at page 1, lines 10-12 with the following amended paragraph:

U.S. Patent Application Serial No. 09/791,911 \_\_\_\_\_ "A Circuit Pattern  
Inspection Method And Apparatus," by Takashi Hiroi, ~~et.~~ et al., filed February 22, 2001  
(Attorney Docket No. 16869P-017800).